

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Tamio ENDO, et al.**

Serial Number: **Not Yet Assigned**
(§371 of International Application Number PCT/JP03/04750)

Filed: **October 15, 2004**

For: **RESIST FILM REMOVING APPARATUS, RESIST FILM REMOVING METHOD, ORGANIC MATTER REMOVING APPARATUS AND ORGANIC MATTER REMOVING METHOD**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 15, 2004

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed international search report.

A copy of each of the references, except for the U.S. patent publication, is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,
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Enclosures: PTO-1449; References (7); International Search Report